



HIGH PRESSURE RUGGEDIZED DYNAMIC RESPONSE PRESSURE TRANSDUCER

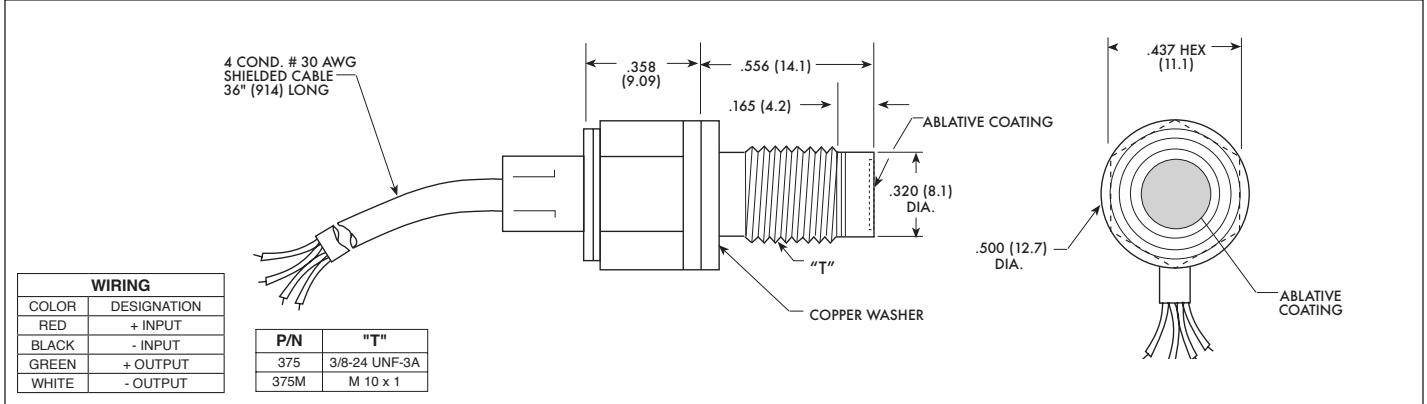
HKS-HP-375 (M) SERIES

- Low Impedance High Output
- Very High Natural Frequency
- Excellent Signal To Noise Ratio
- Silicon on Silicon Integrated Sensor **VIS®**
- Designed For Shock Pressure Applications

Designed for high pressure, high shock environments, this range of transducers is widely used in both military and commercial applications.



Kulite recommends the [KSC Series](#) of signal conditioners to maximize the measurement capability of the HKS-HP-375 transducer.



| | | | | | | | | | |
|---------------|--|---|----------------------|----------------------|----------------------|----------------------|----------------------|-----------------------|-------------|
| INPUT | Pressure Range | 35 500 | 70 1000 | 140 2000 | 350 5000 | 700 10000 | 1400 20000 | 2100 BAR 30000 PSI | |
| | Operational Mode | Sealed Gage | | | | | | | |
| | Over Pressure | 70 1000 | 100 1500 | 210 3000 | 510 7500 | 1000 15000 | 1700 25000 | 2450 BAR 35000 PSI | |
| | Burst Pressure | 140 2000 | 210 3000 | 420 6000 | 840 12000 | 1400 20000 | 2100 30000 | 2800 BAR 40000 PSI | |
| | Pressure Media | Any Liquid or Gas Compatible With 15-5 PH, 316 Stainless Steel and Silicone RTV and Copper Crush Ring | | | | | | | |
| | Rated Electrical Excitation | 5 VDC/AC | | | | | | | |
| | Maximum Electrical Excitation | 7.5 VDC/AC | | | | | | | |
| | Input Impedance | 1000 Ohms (Nom.) | | | | | | | |
| OUTPUT | Output Impedance | 1000 Ohms (Nom.) | | | | | | | |
| | Full Scale Output (FSO) | 100mV (Nom.) | | | | | | | 75mV (Nom.) |
| | Residual Unbalance | ± 5 mV (Typ.) | | | | | | | |
| | Combined Non-Linearity, Hysteresis and Repeatability | ± 0.1% FSO BFSL (Typ.) ± 0.5% FSO (Max.) | | | | | | | |
| | Resolution | Infinitesimal | | | | | | | |
| | Natural Frequency of Sensor Without RTV (KHz) (Typ.) | 400 | 720 | 900 | 1120 | 1350 | 1600 | 1800 | |
| | Acceleration Sensitivity % FS/g Perpendicular | 1.1x10 ⁻⁴ | 6.2x10 ⁻⁵ | 2.7x10 ⁻⁵ | 1.5x10 ⁻⁵ | 1.3x10 ⁻⁵ | 8.6x10 ⁻⁶ | 6.0x10 ⁻⁶ | |
| | Insulation Resistance | 100 Megohm Min. @ 50 VDC | | | | | | | |
| ENVIRONMENTAL | Operating Temperature Range | -65°F to +300°F (-55°C to +150°C) | | | | | | | |
| | Compensated Temperature Range | 80°F to +180°F (25°C to +80°C) Any 100°F Range Within The Operating Range on Request | | | | | | | |
| | Thermal Zero Shift | ± 6% FS/100°F (Typ.) | | | | | | | |
| | Thermal Sensitivity Shift | ± 6% /100°F (Typ.) | | | | | | | |
| | Linear Vibration | 20g Peak, Sine 10 to 2000 Hz | | | | | | | |
| | Mechanical Shock | 20g Half Sine Wave 11 msec. Duration | | | | | | | |
| PHYSICAL | Electrical Connection | 4 Conductor 30 AWG Shielded Cable 36" Long | | | | | | | |
| | Weight | 10 Grams (Nom.) Excluding Cable | | | | | | | |
| | Pressure Sensing Principle | Fully Active Four Arm Wheatstone Bridge Dielectrically Isolated Silicon on Silicon | | | | | | | |
| | Mounting Torque | 80-120 Inch-Pounds (Max.) | | | | | | | |
| | Diaphragm Coating | Ablative Coating Standard | | | | | | | |

Note: Custom pressure ranges, accuracies and mechanical configurations available. Dimensions are in inches. Dimensions in parenthesis are in millimeters. All dimensions nominal. (R) Continuous development and refinement of our products may result in specification changes without notice. Copyright © 2014 Kulite Semiconductor Products, Inc. All Rights Reserved. Kulite miniature pressure transducers are intended for use in test and research and development programs and are not necessarily designed to be used in production applications. For products designed to be used in production programs, please consult the factory.